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IPW

AMENDMENT UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
GROUP 2814  
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79657

Kazutoshi SHIBA, et al.

Appln. No.: 10/767,335

Group Art Unit: 2814

Confirmation No.: 5230

Examiner: Shrinivas H. RAO

Filed: January 30, 2004

For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME

AMENDMENT UNDER 37 C.F.R. § 1.116

**MAIL STOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 22, 2005, please amend the above-identified application as follows on the accompanying pages.

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